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MATERIAL COVERED WITH CARBON
FILM OF OFFICE SUPPLIES

Abstract:

PURPOSE: To increase abrasion resistance, prevent dust settlement and also generation of static electricity by providing film consisting of carbon or mainly of carbon, with a specifically inherent resistance to the surface of an organic substance and also light permeability.

CONSTITUTION: A thin film is formed which is composed mainly of carbon film or carbon. This carbon film or carbon has a similar C-C bond to diamond with an SP

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